

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT						
NATURE OF CONVEYANCE:	ASSIGNMENT						
CONVEYING PARTY DATA							
<table border="1"><thead><tr><th>Name</th><th>Execution Date</th></tr></thead><tbody><tr><td>Osamu KOBAYASHI</td><td>03/14/2006</td></tr><tr><td>Toshihiko ISHIDA</td><td>03/14/2006</td></tr></tbody></table>	Name	Execution Date	Osamu KOBAYASHI	03/14/2006	Toshihiko ISHIDA	03/14/2006	
Name	Execution Date						
Osamu KOBAYASHI	03/14/2006						
Toshihiko ISHIDA	03/14/2006						
RECEIVING PARTY DATA							
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State/Country:	JAPAN						
Postal Code:	311-1112						
PROPERTY NUMBERS Total: 1							
<table border="1"><thead><tr><th>Property Type</th><th>Number</th></tr></thead><tbody><tr><td>Application Number:</td><td>11401035</td></tr></tbody></table>	Property Type	Number	Application Number:	11401035			
Property Type	Number						
Application Number:	11401035						
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Total Attachments: 1 source=Hohjoh 4372.P0054US Assignment#page1.tif							

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ASSIGNMENT

United States (Sole or Joint)
(Excluding Foreign Rights)

WHEREAS, I/We, (1) Osamu Kobayashi (2) Toshihiko Ishida

residing at (1) and (2) c/o Viotech Japan Co., Ltd. 513, Kawamatacho, Mito-shi, Ibaraki-ken 311-1112, Japan

have invented certain new and useful improvements in A MOLECULAR BEAM SOURCE FOR USE OF THIN-FILM ACCUMULATION AND A METHOD FOR CONTROLLING VOLUME OF MOLECULAR BEAM for which an application for United States Letters patent was signed by us herewith on even date

WHEREAS, Viotech Japan Co., Ltd.

having a place of business at 513, Kawamatacho, Mito-shi, Ibaraki-ken 311-1112, Japan

hereinafter called the "Assignee", is desirous of acquiring the entire right, title and interest in and to said invention and in and to any Letters Patent that may be granted therefor, in the United States and its territorial possessions.

NOW, THEREFORE, in consideration of the sum of One Dollar (\$1.00) and other valuable considerations, the receipt whereof is hereby acknowledged, I/we have sold, assigned and transferred, and by these presents do sell, assign, transfer and confirm in and to said Assignee my/our full and exclusive right to the said invention in the United States and its territorial possessions and my/our entire right, title and interest in and to said application and any and all Letters Patent which may be granted therefor in the United States and its territorial possessions and in and to any and all divisions, reissues, continuations and extensions thereof.

I/We hereby authorize and request the Patent Office Officials in the United States to issue any and all of said Letters Patent, when granted, to said Assignee for the sole use and behoof of the said Assignee, its successors and assigns.

IN TESTIMONY WHEREOF, I/we have hereunto set my/our hand(s).

Witnessed by:

Shinichiro Kikuchi

Shinichiro Kikuchi

Inventor(s):

Date:

Osamu Kobayashi
Osamu Kobayashi

March 14, 2006

Toshihiko Ishida
Toshihiko Ishida

March 14, 2006

PATENT